



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Donald L. Yates

Serial No.: 10/027,951

Filed: December 19, 2001

**For:** METHOD OF REDUCING WATER SPOTTING AND OXIDE GROWTH ON A

SEMICONDUCTOR STRUCTURE

**Confirmation No.: 2633** 

Examiner: A. Markoff

Group Art Unit: 1746

Attorney Docket No.: 2269-3375.6US

(95-0999.5)

Notice of Allowance Mailed:

August 30, 2004

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November 30, 2004

Person making Deposit:

Steve Wong

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 10 of this paper.

Remarks begin on page 16 of this paper.